

List of designations

100 schematic block diagram of a setup of a semiconductor production installation
101 block of an overall manufacturing process
102 block of a first production area
103 block of a second production area
104 block of a third production area
105 block of a fourth production area
200 semiconductor chip production installation
201 multiplicity of semiconductor chip production sub-installations
202 path of a wafer or a lot through the semiconductor chip production installation
201 machine
301 sensor
302 SECS interface
303 PDSF file
304 log file
306 local communication network (LAN)
307 memory
308 evaluation unit
409 limit value of the misalignment value
410 wafer exceeding the limit value (FDC defect)
411 wafer exceeding the limit value (FDC defect)